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## \*BIBDATASHEET\*

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**CONFIRMATION NO. 8666** 

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SERIAL NUMBER 10/693,683	1 1		CLASS 451		GROUP ART UNIT 3723		ATTORNEY DOCKET NO. 007985/CMP/CMP		
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** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
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met Verified and	yes in no in Met after	Initials	COUNTRY CA	DRA	DRAWING 3		IMS 4	CLAIMS 4	
ADDRESS APPLIED MATERIALS, INC. PATENT COUNSEL Legal Affairs Department P.O. Box 450A Santa Clara, CA 95052									
TITLE Polishing processes for shallow trench isolation substrates									
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FILING FEE FEES: Authority has been given in Paper						☐ 1.17 Fees ( Processing Ext. of			